## **WEST Search History**

Hide Items Restore Clear Cancel

DATE: Monday, September 26, 2005

Hide?	Set Name	Query	Hit Count
	DB=USF	PT; PLUR=YES; OP=OR	
	L23	121 and L22	49
	L22	427/\$7.ccls.	86791
	L21	L20 and multilayer	219
	L20	L19 and 13 and 15	1218
$\Box$	L19	rhenium	12221
	L18	L17 and 13 and 15	5
	L17	rhenium near5 carbonyl	180
	L16	rhenium and 113	4
	L15	13 and L13	57
	L14	11 and 113	0
	L13	17 or 18 or 19 or 110 or 111 or L12	66
	L12	jamison adj paul.in.	11
	L11	mcfeely adj fenton.in.	23
	L10	leusink adj gert.in.	4
	L9	kawano adj yumiko.in.	22
	L8	nakamura adj kazuhito.in.	7
	. L7	yamasaki adj hideaki.in.	12
	L6	11 and 13 and L5	3
	L5	substrate or wafer	576949
	L4	11 and 12 and L3	0
$\Box$	L3	vapor adj deposition or cvd	108409
	L2	substrat or wafer	135060
	L1	rhenium adj carbonyl	115

END OF SEARCH HISTORY

## **WEST Search History**

Hide Items Restore Clear Cancel

DATE: Monday, September 26, 2005

Hide? Set Name Query			Hit Count
	L17	L16 and rhenium	1
	L16	5209388.pn.	1
	L15	6884466.pn. and 17	1
	L14	5145716.pn. and 17	0
$\Box$	L13	5209388.pn. and 17	0
	L12	5549937.pn. and 17	1
	L11	5952421.pn.	1
	L10	5952421.pn. and 17	0
	L9	5618395.pn. and 17	1
	L8	16 and L7	0
	L7	rhenium and multilayer	768
	L6	6540800.pn.	1
$\Box$	L5	multilayer and 12	24
	L4	multilayer and 13	0
$\Gamma$	L3	carbonyl and 12	28
	L2	rhenium same 11	296
	Ļ1	cvd or vapor adj deposition	108409

**END OF SEARCH HISTORY**